



Attorney Docket No.: 42390.P7068
Confirmation No.: 7737

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Peng Cheng, et al.

Application No.: 09/343,293

Examiner: Edgardo Ortiz

Filed: June 30, 1999

Art Unit: 2815

Attorney Docket No.: 042390.P7068

For: TRANSISTOR STRUCTURE
HAVING SILICIDE
SOURCE/DRAIN EXTENSIONS

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

UNDER 37 CFR 1.116

Sir:

In response to the Final Office Action mailed March 19, 2003, applicants respectfully request that the above-identified application be amended as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on June 24, 2003

Beverly Kehoe Shea

(Typed or printed name of person mailing correspondence)

(Signature of person mailing correspondence)

21/11/03
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F10-03
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8/20/03

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JUN 30 2003
TECHNOLOGY CENTER 2800

Beverly Kehoe Shea 6/24/03